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## BIB DATA SHEET

CONFIRMATION NO. 9556

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP05/01937 02/09/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2004-032670 02/09/2004

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***

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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	JAPAN	7	7	4
Verified and <u>/ELISA CARLA HITESHEW</u>						
Acknowledged <u>Examiner's Signature</u>	<u>Initials</u>					

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**TITLE F**

Single crystal semiconductor manufacturing apparatus and method

<b>FILING FEE RECEIVED</b> 1100	<p>FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:</p>	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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